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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

-----: Atty.#: AIR-P1
In Re U.S. Patent Application Of :
KULP :
Serial No.: 09/905,287 : Examiner:
Filing Date: July 13, 2001 : Group No: 1744
Title: UV AIR CLEANING SYSTEM :
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INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents
Washington, D.C. 20231

Sir:

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MAR 13 2002
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This Information Disclosure Statement is filed in accordance with 37 C.F.R. 1.56, 1.97, and 1.98. The reference(s) listed on the appended PCT International Search Report for the corresponding PCT International Application, may be deemed to be pertinent to the above-identified patent application and are made of record to assist the U.S. Patent Office in its examination of the same.

Copies of the above-noted references are available to the Examiner from the corresponding PCT International Application US01/22462 filed with the U.S. Patent Office as PCT Designated Office and as International Searching Authority.

No fee is deemed to be due with this Statement as it is

CERTIFICATE OF MAILING:

The undersigned certifies that the foregoing is being mailed on February 11, 2002, by depositing it with the U.S. Postal Service, first class postage paid, addressed to Asst. Commissioner for Patents, Box: Non-Fee, Washington, D.C., 20231.

Respectfully submitted,
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